Se	arch Notes	

Application/Control No.	Applicant(s)/Patent und Reexamination	der
10/554,267	TAKEMURA ET AL.	
Examiner	Art Unit	
Marlon A. Arce-Diaz	3611	

	SEAR	CHED	
Class	Subclass	Date	Examiner
180	8.1,8.6, 8.5	12/6/2007	MAA
901	1,701	12/6/2007	МАА
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner

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